

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hiroyuki HIGUCHI et al. Confirmation: 2642  
Serial No. : 10/537,361 Art Unit : 1713  
Filing Date: August 19, 2005  
Title : POLYARYLENE SULFIDE RESIN, COMPOSITION THEREOF,  
AND PROCESSES FOR PRODUCING THESE

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(c)(1)**

Customer Window  
U.S. Patent & Trademark Office  
Randolph Building  
401 Dulany St.  
Alexandria, Virginia 22314

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449.

The references listed on Form PTO-1449 were cited in a Search Report mailed September 11, 2006, copy enclosed, in corresponding European Application No. 038123170.0.

Inasmuch as each item filed herewith was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this submission, no fee is due.

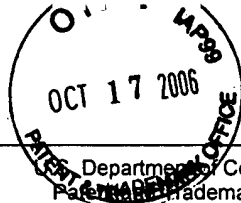
It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The Commissioner is hereby authorized to charge any fees due to Deposit Account No. 19-4293.

Respectfully submitted,

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Form PTO-1449 (Modified)	Department of Commerce Patent and Trademark Office	Attorney's Docket No. 28955.1051	Application No. 10/537,361
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))		Applicant <b>Hiroyuki HIGUCHI et al</b>	
		Filing Date August 19, 2005	Group Art Unit 1713

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,388,003	5/2002	Okamoto et al	524	609	
	AB	2002/0128372	9/2002	Okamoto et al	524	494	
	AC	2002/0062003	5/2002	Okamoto et al	528	388	

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AP	
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	